App. No. 10/607,613 Amend. Dated 8/29/05

Response To Action dated 6/10/05

AUG 3 1 2005

**PATENT** 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE In re the application of Examiner: Rachuba, Maurina T. Kiermasz et al. Art Unit: 3723 Application No: 10/607,613 Atty. Docket No: LAM2P421 Filed: June 27, 2003 Date: August 29, 2005 PLATEN WITH DIAPHRAGM AND METHOD FOR OPTIMIZING WAFER) **POLISHING** 

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on Augus 129, 2005.

Signed

## SUBMISSION UNDER 37 CFR 1.114

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Honorable Commissioner:

In response to the Final Office Action mailed June 10, 2005, which set a three month shortened period for response, please consider this as a Submission under 37 CFR 1.114, amend the captioned application as follows, and consider the following remarks.

Amendments to the claims start on page 2.

Remarks start on page 13.